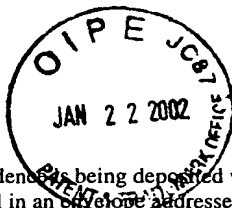


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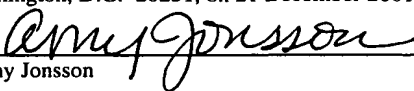
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Amy Jonsson

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Christophe Pierrat et al.)

Application No.: 09/972,428)

Filed: 5 October 2001)

Title: **EXPOSURE CONTROL FOR PHASE
SHIFTING PHOTOLITHOGRAPHIC
MASKS**)

Group Art Unit: 2812

Examiner: Not yet assigned

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner of Patents
Washington, D.C. 20231

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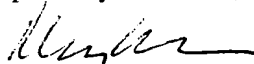
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Please change the name of the second inventor from "Michael Luc Cote" to - - **Michel Luc Cote** - -.

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Respectfully submitted,



Date: 18 December 2001

Mark A. Haynes
Registration No. 30,846

NUMERICAL C/O:
HAYNES BEFFEL & WOLFELD LLP
P.O. Box 366
Half Moon Bay, CA 94019
Phone: (650) 712-0340



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/972,428	10/05/2001	2812	1538	NMTI 1002-4	6	55	5

CONFIRMATION NO. 3974

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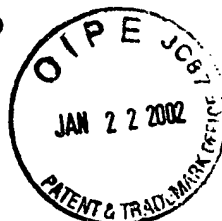
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Applicant(s)

Christophe → Christophe Pierrat, Santa Clara, CA;
Michel → Michael Luc Cote, San Jose, CA;

Domestic Priority data as claimed by applicant

THIS APPLN CLAIMS BENEFIT OF 60/296,788 06/08/2001
AND CLAIMS BENEFIT OF 60/304,142 07/10/2001

HAYNES BEFFEL & WOLFELD LLP

NOV 14 2001

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Foreign Applications

If Required, Foreign Filing License Granted 11/08/2001

Projected Publication Date: 12/12/2002

Non-Publication Request: No

Early Publication Request: No

Title

Exposure control for phase shifting photolithographic masks

Preliminary Class

438

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TC 2002-01-11-1011
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